



**ADDITIONAL INFORMATION  
DISCLOSURE  
STATEMENT BY APPLICANT  
PTO-1449**

DOCKET NO.  
10191/3980

SERIAL NO.  
10/519,724

APPLICANT  
Franz LAERMER

FILING DATE  
December 28, 2004

GROUP  
1763

**U. S. PATENT DOCUMENTS**

EXAMINER INITIAL	PATENT/PUBLICATION NUMBER	PATENT/PUBLICATION DATE	NAME	CLASS	SUBCLASS	FILING DATE
/RD/	US 2002/074946	June 20, 2002	Tetsuya et al.			
/RD/	4,472,254	September 18, 1984	Dotson et al.			
/RD/	6,190,507	February 20, 2001	Bigelow et al.			

**FOREIGN PATENT DOCUMENTS**

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						Yes	No
/RD/	00 51938	September 8, 2000	WO				
/RD/	2001 267241*	September 28, 2001	JP				
/RD/	2 332 302	June 16, 1999	GB				
/RD/	199 19 469*	November 2, 2000	DE				
/RD/	08-153711*	June 11, 1996	JP				
/RD/	43 17 623*	December 1, 1994	DE				

\* English language abstract provided.

**OTHER DOCUMENTS**

EXAMINER INITIAL	AUTHOR, TITLE, DATE, PERTINENT PAGES, ETC.	
/RD/	Joudan et al., "Recent Developments in Fluorine Chemistry for Microelectronic Applications – Some Examples at Comurhex", Journal of Fluorine Chemistry, Elsevier Seguoia, Lausanne, CH, Bd. 107, Nr. 2, February 2001, Pages 255-264, XP004315006, ISSN: 0022-1139, Page 260-262.	
/RD/	Hofmann-Rüdorff, "Textbook of Inorganic Chemistry", 21 <sup>st</sup> Edition, 1973, pgs. 259 et. sqq.	
EXAMINER	/Rakesh Dhingra/	DATE CONSIDERED 09/15/2007
EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.		